

2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3
Election

In re the Application of:

Xiaoju Wu

Docket No.: TI-33005

Serial No.: 09/997,972

Examiner: Lattin, C.

Filed: 11/29/2001

Art Unit: 2812

For: METHOD FOR MANUFACTURING AND STRUCTURE OF
SEMICONDUCTOR DEVICE WITH POLYSILICON DEFINITION STRUCTURE

J. Minnion
6/12/03

ELECTION

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

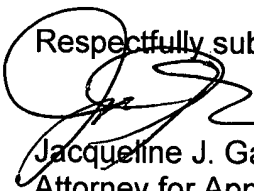
MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(A)
I hereby certify that the above correspondence is being deposited
with the U.S. Postal Service as first Class Mail in an envelope
addressed to Assistant Commissioner for Patents, PO Box 1450,
Alexandria, VA 22313-1450.

6-5-03
Date Marianna Smith
Marianna Smith

Dear Sir:

With respect to the Restriction Requirement mailed on 5/15/2003, the Examiner has restricted the instant application to the invention of Group I (Claims 1-11), or Group II (Claims 12-21). In light of this, Applicant elects to pursue Group I, (Claims 1-11) without traverse.

Respectfully submitted


Jacqueline J. Garner
Attorney for Applicant
Reg. No. 36,144

Texas Instruments Incorporated
P.O. Box 655474, M/S 3999
Dallas, TX 75265
(214) 532-9348 or
(972) 917-5643
Fax: (972) 917-4418